

## Charge collection measurement on slim edge sensors with the ALiBaVa system.

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We report the charge collection measurement on p-on-n micro strip sensors with slim edges.

The sensors were “GLAST” style sensors manufactured by HPK with 228 micron pitch. The edge was produced by PECVD deposition of Nitride and was 50 micron from the outer edge of the guard ring, about 200 micron from the active area.

We find constant charge collection even in the last trip before and after cutting the edge.

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